A Robust Multivariate Profile Monitoring Framework

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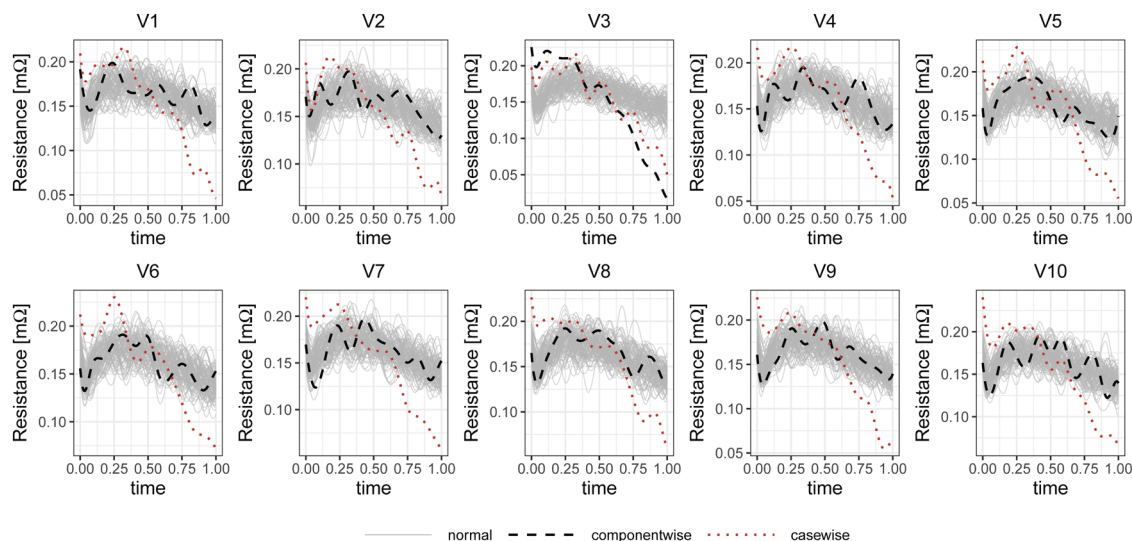# A Robust Multivariate Profile Monitoring Framework

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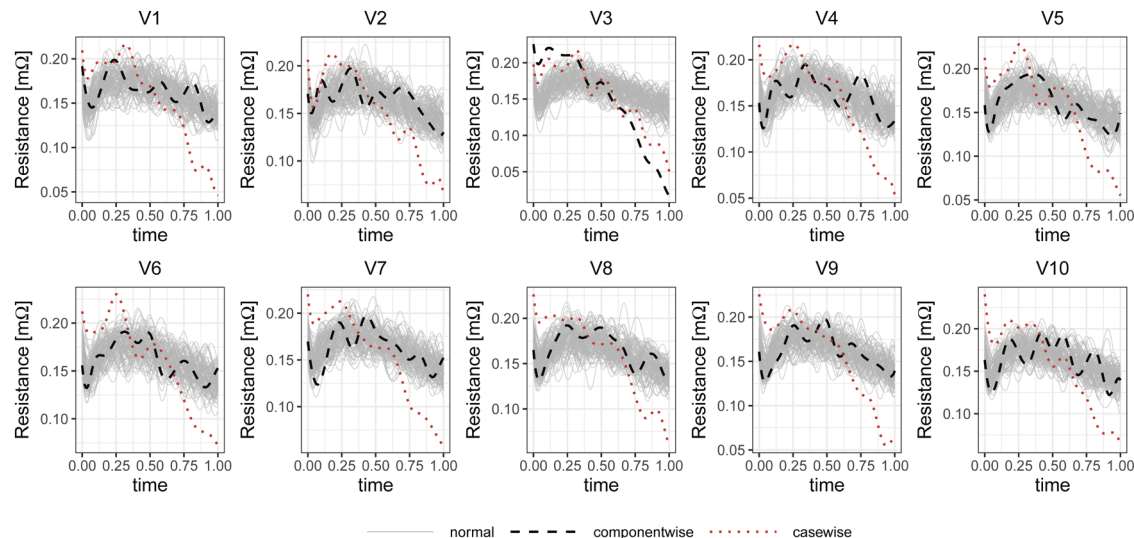
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- Outliers may realistically occur in one or a few components only (componentwise), rather than in all components (casewise).

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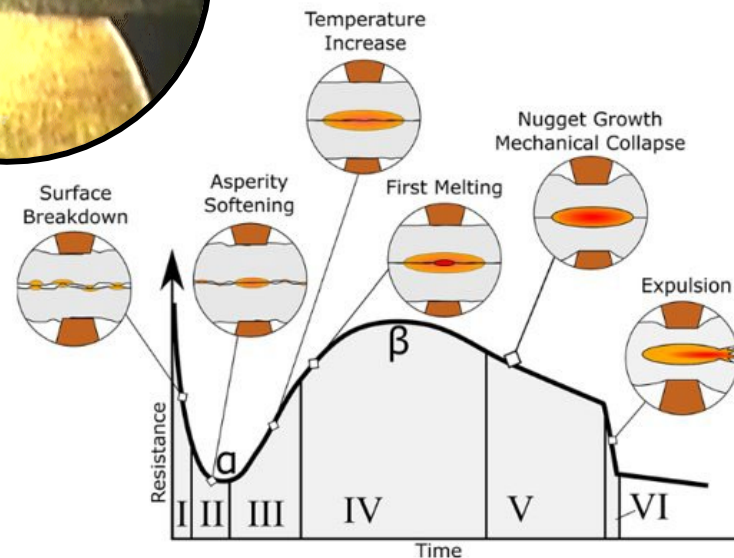- The RoMFCC is implemented in the R package `funcharts`, openly available on CRAN.
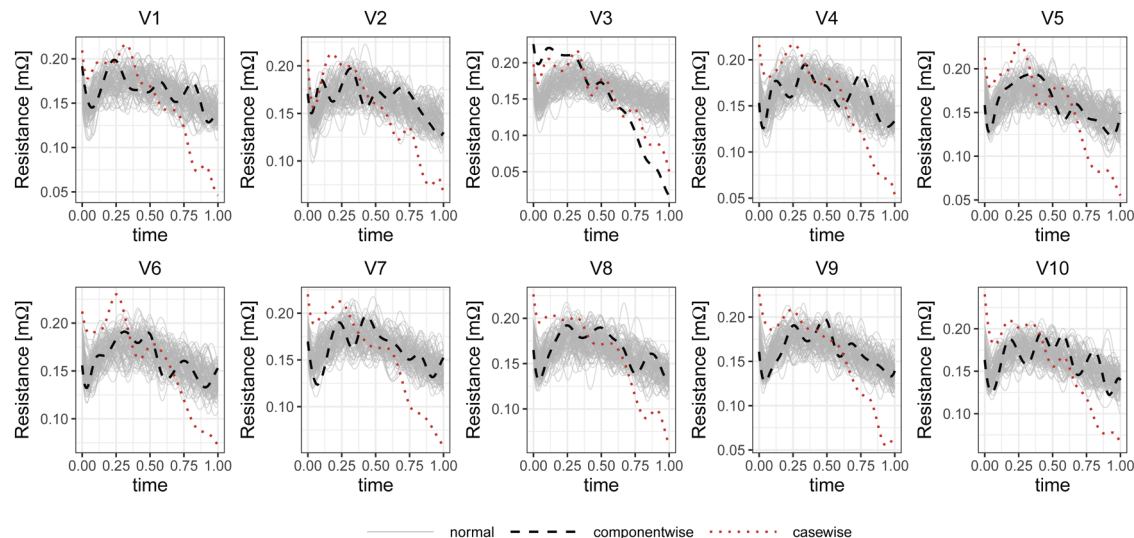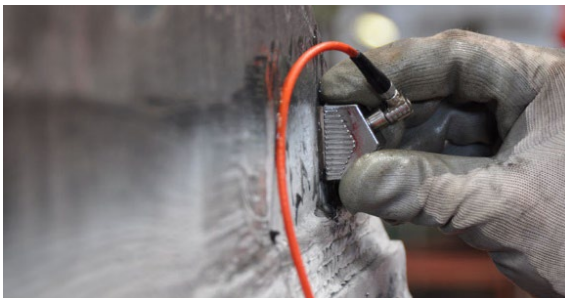
Real-case study: resistance spot welding process

- Resistance spot welding (**RSW**) process (Dickinson et al, 1980)
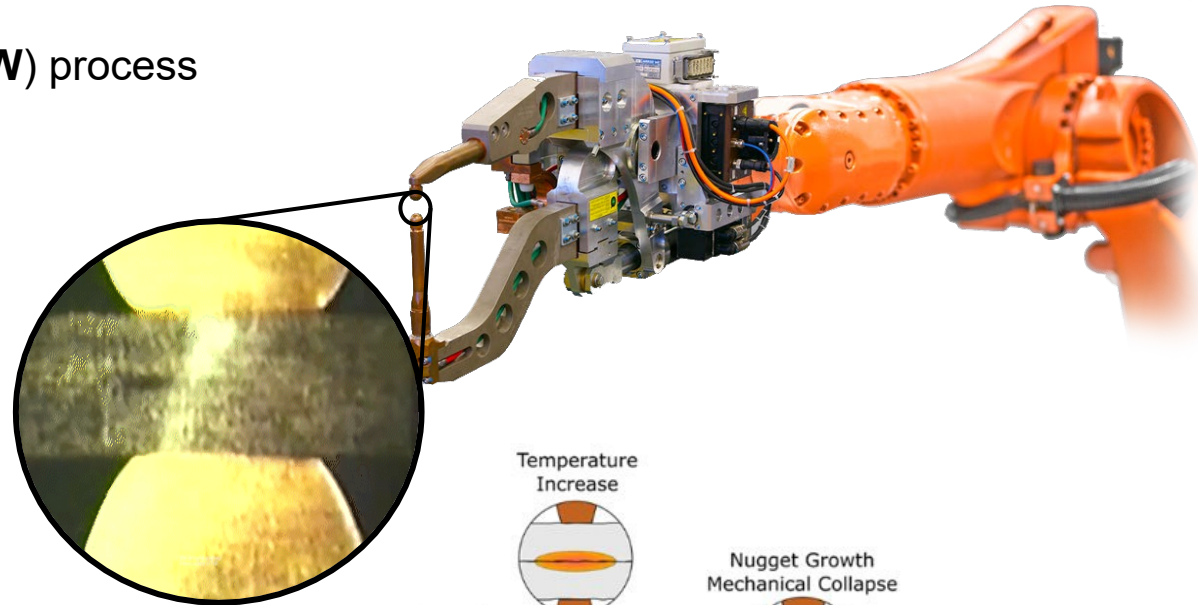
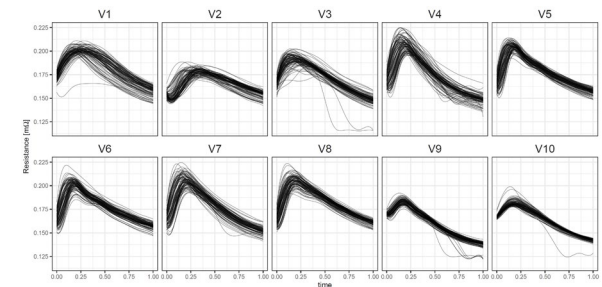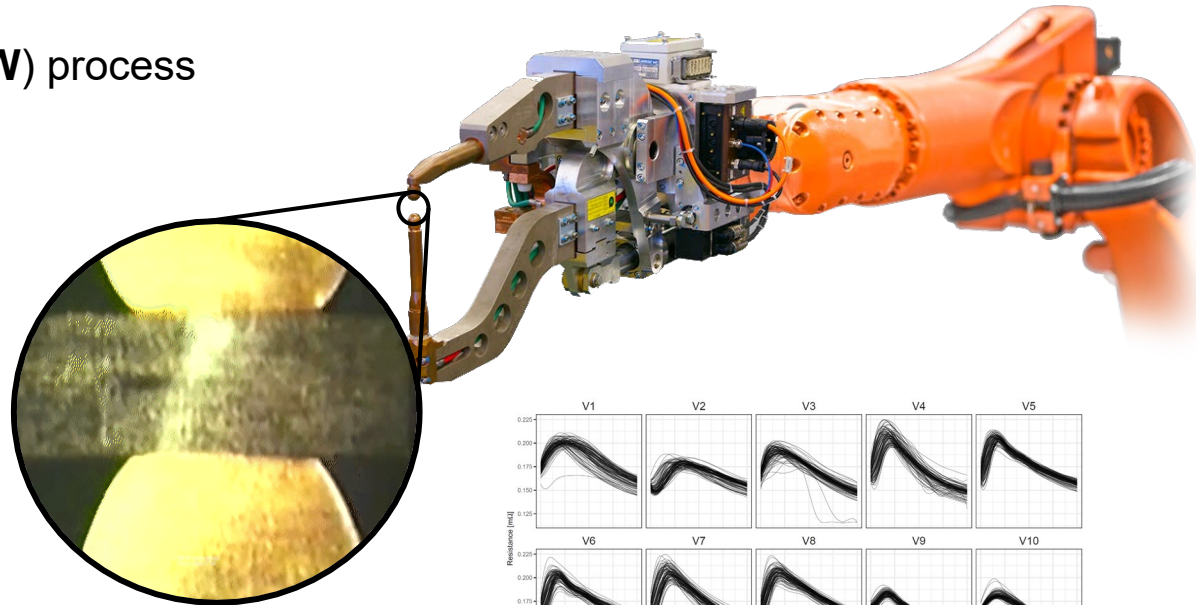- Technological signature of the process: the dynamic resistance curve (**DRC**)
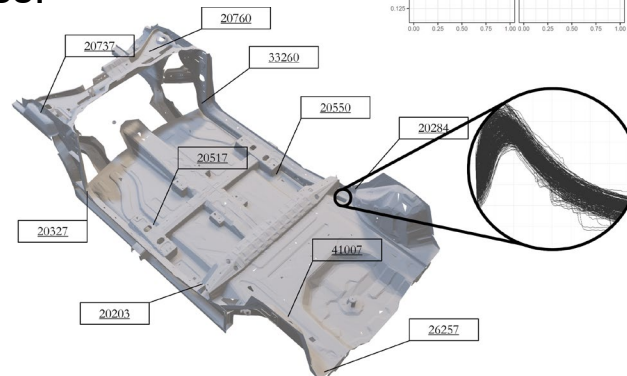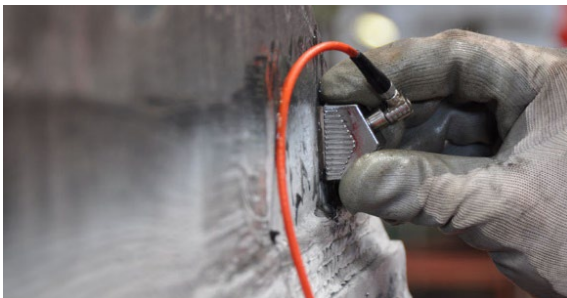
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